IeCAT 2020

Session: **Actuator Materials**Chair: **Prof. Dr. Kenji Uchino**

Time (EST)	November 25 th
8:30 - 8:35	Dr. Kenji Uchino, Penn State University, USA
Start	Introduction of Session "Actuator Materials"
8:35 – 9:10	Dr. Clive Randall, Penn State University, USA
Keynote talk 1	Opportunities for Cold Sintering Materials for Capacitive and Piezoelectric Appli-
	cations
9:10 - 9:45	Dr. Isaku Kanno, Kobe University, Kobe, Japan
Keynote talk 2	PZT thin films for Piezo MEMS: deposition, characterization, and application
9:45 – 10:20	Dr. Jongho Ryu, Yeungnam University, Gyeongbuk, Korea
Keynote talk 3	Piezoelectric Thick film fabrication by Aerosol Deposition; applications and ad-
	vances
10:20 – 10:30	Wrap up and concluding remarks, Session Chair Dr. Kenji Uchino
Keynote talk 4	High Power Piezoelectrics – Future Trend

Please note that the time zone is EST (Eastern Standard Time).

Keynote talk time: 30 min. talk and 5 min. q&a.